

## LETI: YOUR PARTNER FOR INNOVATIVE MEMS SOLUTIONS

6:00 – 6:15 p.m.

### Registration and Welcome



6:15 – 6:25 p.m.

### "Leti, your R&D Partner working for Industry"

Jean René Lequepeys - VP Silicon Components division



6:25 – 6:40 p.m.

### "Advanced multi-purposes MEMS and NEMS Platforms of Leti"

Julien Arcamone - MEMS Business Development Manager



6:40 – 6:50 p.m.

### "Piezoelectric Technologies and Devices at Leti"

Philippe Robert - Head of Microsystems & Packaging Section



6:50 – 7:00 p.m.

### "Highlight on Leti's Gas sensors Technologies"

Eric Ollier - M&NEMS expert



7:00 – 7:10 p.m.

### "Highlight on Leti's state-of-the-art Characterization Platform for Microsystems"

Guillaume Jourdan - M&NEMS expert



7:10-7:20 p.m.

### "Suspended Microchannel Resonators for nanoparticles and biological cells characterization "

Vincent Agache - MEMS expert

7:20-7:30p.m.

### Conclusion

7:30 – 8:40 p.m.

### Networking event

